

**Docket No.: 4425-320**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:
	:
Chien-Hsin LAI <i>et al.</i>	: Confirmation No. 3535
	:
U.S. Patent Application No. 10/659,258	: Group Art Unit: 1763
	:
Filed: September 11, 2003	: Examiner: Karla A Moore

For: PLASMA APPARATUS AND METHOD CAPABLE OF ADAPTIVE IMPEDANCE  
MATCHING

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 12, 2006, please amend the above-identified application as follows: